

Docket No.: 52352-785

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
George Jonathan KLUTH, et al. :
Serial No.: Group Art Unit:
Filed: February 11, 2002 Examiner:
For: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE WITH
SUPERSATURATED SOURCE/DRAIN EXTENSIONS AND METAL SILICIDE
CONTACTS



CLAIM OF PRIORITY

Commissioner for Patents
Washington, DC 20231

Sir:

In accordance with the provisions of 35 U.S.C. 119, Applicants hereby claim the priority of:

United States Provisional Patent Application No. 60/267,407, filed February 9, 2001

Respectfully submitted,

MCDERMOTT, WILL & EMERY

A handwritten signature of Bernard P. Codd.

Bernard P. Codd
Registration No. 46,429

600 13th Street, N.W.
Washington, DC 20005-3096
(202) 756-8000 BPC:mlw
Date: February 11, 2002
Facsimile: (202) 756-8087